

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Gu, et al.	
Application No.: 10/773665	Art Unit: 2125
Filed: 2/6/04	Examiner: Sheela Rao
Title: Dynamically Coupled Metrology and Lithography	
Attorney Docket No.: IDT-1790	
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	

AMENDMENT AFTER NOTICE OF ALLOWANCE

(37 C.F.R. § 1.312)

Dear Sir:

Applicants request that the present amendments be entered.

**Amendments to the specification** begin on page 2 of this paper.

**Amendments to the claims** begin on page 4 of this paper.

**Remarks** begin on page 13 of this paper.